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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/728,814	12/08/2003	Jess Koehler	Q78708	9247
23373	7590	03/08/2006		
SUGHRUE MION, PLLC 2100 PENNSYLVANIA AVENUE, N.W. SUITE 800 WASHINGTON, DC 20037			EXAMINER SUGARMAN, SCOTT J	
			ART UNIT	PAPER NUMBER
			2873	

DATE MAILED: 03/08/2006

Please find below and/or attached an Office communication concerning this application or proceeding.



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In re Application of KOEHLER :

Appl. No.: 10/728,814 :

Filed: December 8, 2003 :

For: OPTICAL SYSTEM FOR PROVIDING A :
USEFUL LIGHT BEAM INFLUENCED BY :
POLARIZATION :

**DECISION ON PETITION
UNDER 37 C.F.R. § 1.59**

This is a decision on the petition under 37 C.F.R. § 1.59(b), filed November 4, 2005, to expunge proprietary information from the above-identified application.

The petition is GRANTED.

Petitioner requests that the proprietary information submitted on December 30, 2004, pursuant to MPEP § 724, be expunged from the record. Petitioner states that the Proprietary Information Disclosure Statement contains proprietary information of the assignee which has not been publicly disclosed. The petition is accompanied by a check of \$130.00 covering the petition fee set forth in 37 CFR 1.17(I).

The information in question has been determined by the examiner to not be material to the examination of the instant application.

Applicant is required to retain the expunged material(s) for the life of any patent which issues on the above-identified application.

The expunged material is returned herewith.

Janice A. Falcone, Group Director
Technology Center 2800

Semiconductors, Electrical and Optical
Systems and Components